## Job Posting (for Assistant Professor)

Affiliation	Laboratory for Materials and Structures, Institute of Innovative Research
Position title	Assistant Professor
Number of Openings	1
Area of Specialization	Development of sub-10 nm scale new electronic materials and their devices
Job Description	The successful candidate will be required to carry out research on
	development of sub-10 nm scale new electronic materials and their
	devices mainly based on experimental investigations.
	• The successful candidate will be required to engage in the education at
	Graduate Major in Materials Science and Engineering, Department of
	Materials Science and Engineering, School of Materials and Chemical
	Technology
	• The successful applicant will have an outstanding track record about the
	investigations of nanoscale electronic materials or their devices in the
	field of solid-state electronics, solid-state physics, solid-state chemistry
Qualifications	or materials science. The successful candidate must have a strong
	commitment to excellence in development of sub-10 nm scale new
	electronic materials and their devices.
	<ul> <li>Applicants must have a Ph.D. degree.</li> </ul>
	Suzukakedai Campus
Location	Nearest station: Suzukakedai
	De facto working hours* under the discretionary labor system:
Working Hours	7 hours 45 minutes per day (38 hours 45 minutes per week)
	*Hours considered as working hours
Term	Fixed-term appointments will be for up to 5 years. Reappointment may be
	possible for one additional term of up to 5 years. The total term is limited to a
	maximum of 10 years from the original date of employment.
Probationary Period	6 months

Salary	<ul> <li>The Institute is currently planning to introduce a new annual salary system in response to new, relevant guidelines of the Ministry of Education, Culture, Sports, Science and Technology, which are expected to be announced around fall 2018. Due to this transition to the new system, the salary will be determined as follows.</li> <li>During the transition period Monthly salary system based on the Regulations on Wage and Salary of the Institute.</li> <li>After the introduction of new system New annual salary system</li> <li>Note: Applicants currently working at other national universities, etc. who have Shokei Staff status (承継職員) and receive an annual salary will be employed under the Institute's current annual salary system).</li> </ul>
Social insurance and	Employee's pension, Mutual Aid Association short-term benefits (health
other benefits	insurance), employment insurance, worker's compensation Insurance.
Employer	President of National University Corporation Tokyo Institute of Technology
Proposed Start Date	April 1st, 2019 or the earliest possible date thereafter
Closing Date for Application	Applications must be received by January 7th, 2019
Selection Process	Selection will be based on a comprehensive review of applications and interviews. Selected applicants may be asked to have an on-campus interview and/or give a presentation.
Required Documents	<ol> <li>Curriculum vitae (with photograph, telephone number, e-mail and mailing addresses) including academic background, professional carrier after high school, applicant's ResearcherID, and library-name of Google Scholar's profile.</li> <li>List of research achievements categorized into the following types: a) refereed original articles, b) proceedings of international conference, c) reviews and commentaries, d) books, e) patents. All authors in the same order as each publication should be clarified. Five representative papers should be marked the symbol of *. Total citation number and h-index (according to Researcher ID) must be specified.</li> <li>Reprints or copies of three significant papers.</li> <li>Academic significance and importance of above five representative papers (A4 paper; 2 pages or less).</li> </ol>

	5) List of acquired research and educational funds (fund name, project title,
	budget, and period of research or education project). Specify whether the
	applicant is the principal investigator or a co-investigator and the total and allotted
	budgets in the case of a co-investigator for each fund. Total amount of obtained
	funds must be given.
	6) Summary of research accomplishments (A4 paper; 2 pages or less).
	7) Research and educational policy after taking this position (A4 paper; 2 pages
	or less)
	8) List of awards received, invited or keynote lectures of international meetings
	and social activity records including activities in academic societies.
	9) List of the name and contact information (affiliation, address, and e-mail
	address) for one person who can evaluate your work.
	10) An excel file down loaded from
	http://www.msl.titech.ac.jp/assets/files/employment/ApplicationForm_e_Name.xlsx
	and filled with required information.
	The required documents must be submitted in hard copy and in USB memory.
How to Submit an	Please write "Application for Assistant Professor at Laboratory for Materials and
Application	Structures" in red ink on the front of the envelope. Applications must be sent by
Application	registered postal mail.
	We do not accept submissions by email or other digital formats.
	Please send your application to:
Where to Submit	Prof. Toshio Kamiya, Office of Laboratory for Materials and Structures, Tokyo
	Institute of Technology, R3-28, 4259 Nagatsuta-cho, Midori-ku, Yokohama 226-
	8503, JAPAN
Contacts	Professor Yutaka Majima,
	Laboratory for Materials and Structures, Tokyo Institute of Technology
	Email: majima@msl.titech.ac.jp
	Tel.: +81-45-924-5309

Other	1.	Application documents will not be returned. The personal information provided in the submitted documents will be used solely for recruitment and not for any other purpose, pursuant to the Institute's applicable rules and regulations.
	2.	Tokyo Institute of Technology, in order to ensure a diverse workforce, guarantees equal opportunities for all individuals regardless of nationality or gender.
	3.	Tokyo Institute of Technology provides start-up funding through an internal supporting system, and successful applicant may have access to such system.
	4.	For more information, please refer to the following link. http://www.hyoka.koho.titech.ac.jp/eprd/recently/koubo/koubo.php?lang=e n